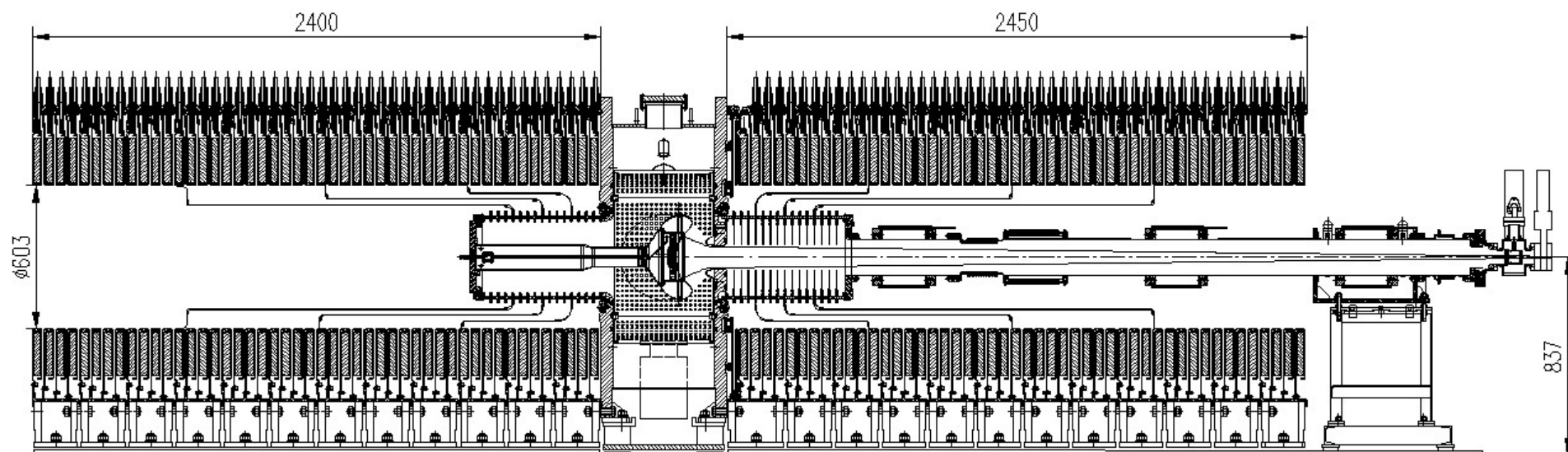


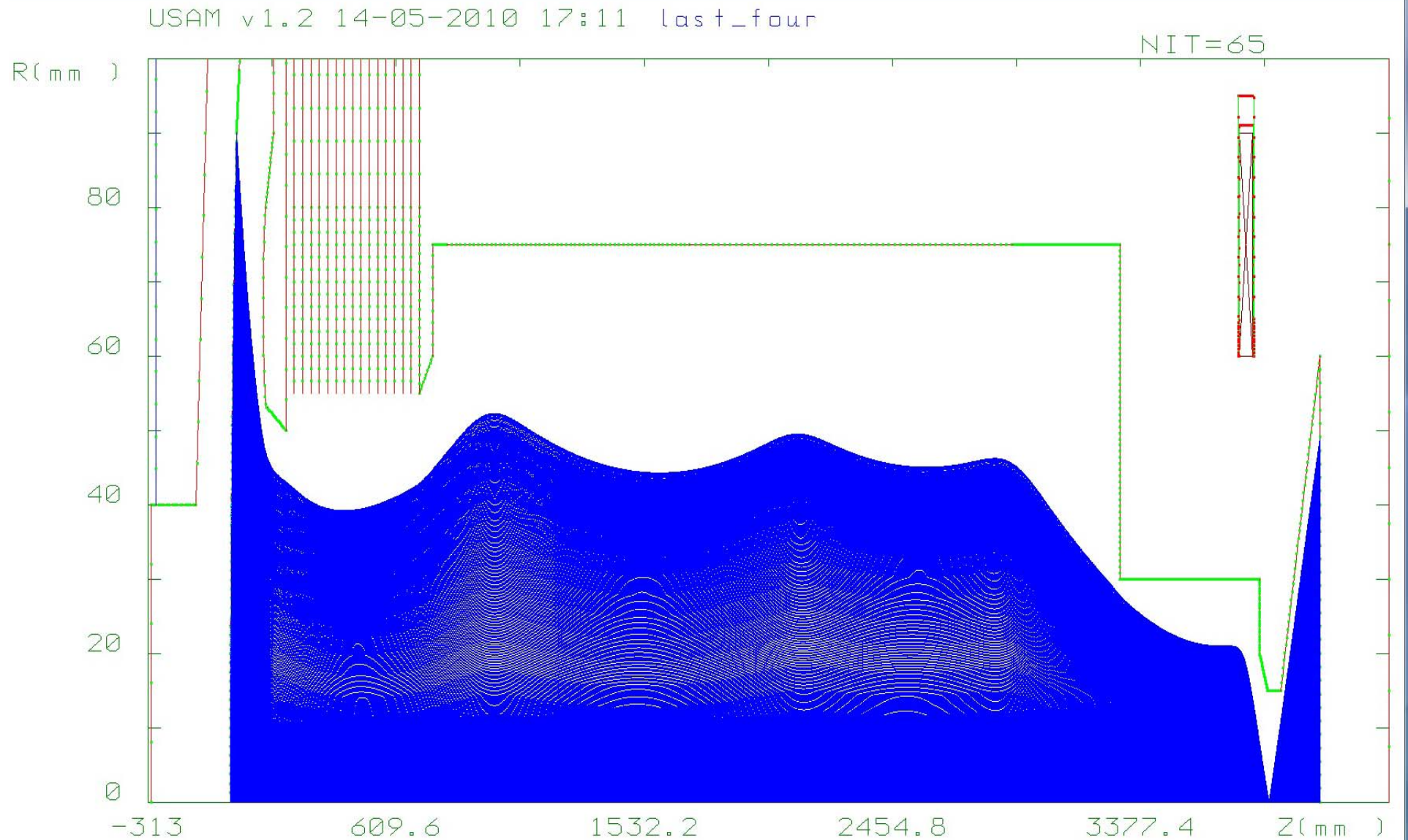
Performance of 2 MeV, 2 kA, 200 ns
Linear Induction Accelerator
with Ultra Low Beam Emittance
for X-ray Flash Radiography

Speaker: Logachev Pavel, BINP SB RAS, Novosibirsk.



Parameter (Units)	Value
Maximum electron beam energy (MeV)	2.0
Maximum electron beam current (kA)	2.0
Number of pulses in the burst	2
Cathode heater DC power (kW)	2.5
Time interval between pulses in the burst (μ s)	2 - 10
Pulse duration, flat top $\pm 4\%$ (ns)	200
Maximum repetition rate (Hz)	0.1
Min. beam spot size FWHM on the target (mm)	1.5

Electron beam envelope at 2 MэВ, 2 кА from cathode up to beam dump.



R(mm)

Electron beam structure near the target

Wmin(keV)= 1460
I(A)= 2017
JM(A/cm**2)= 4e+6
ALFA(MRAD)= 254.779
UTMAX/UZ= 0.24614
EPS(MRAD*mm)= 52.63
R1(mm)= 0
Z1(mm)= 3925
R2(mm)= 0.303
Z2(mm)= 3925

8

6

4

2

0

Ta Target

3900

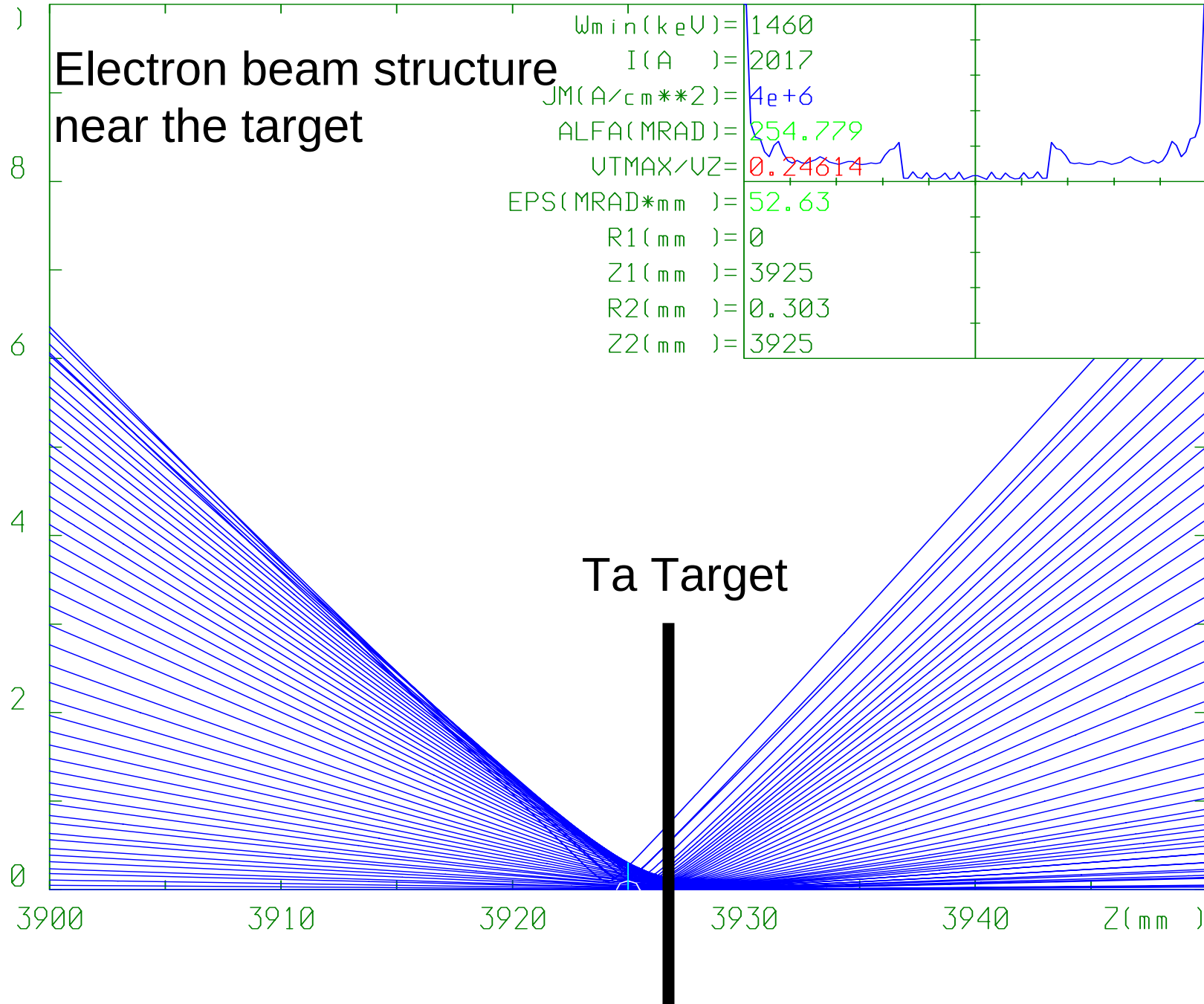
3910

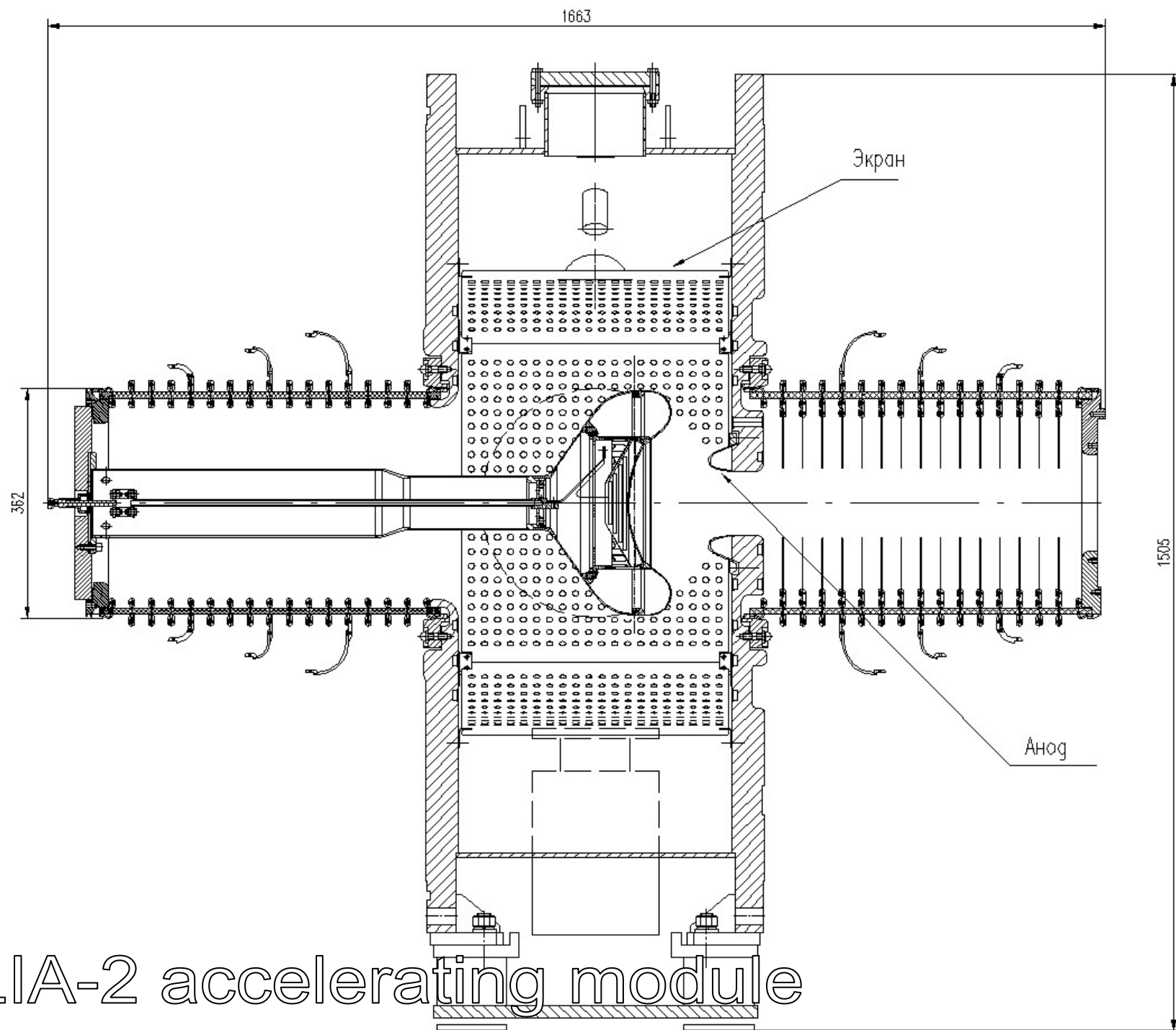
3920

3930

3940

Z(mm)





LIA-2 accelerating module

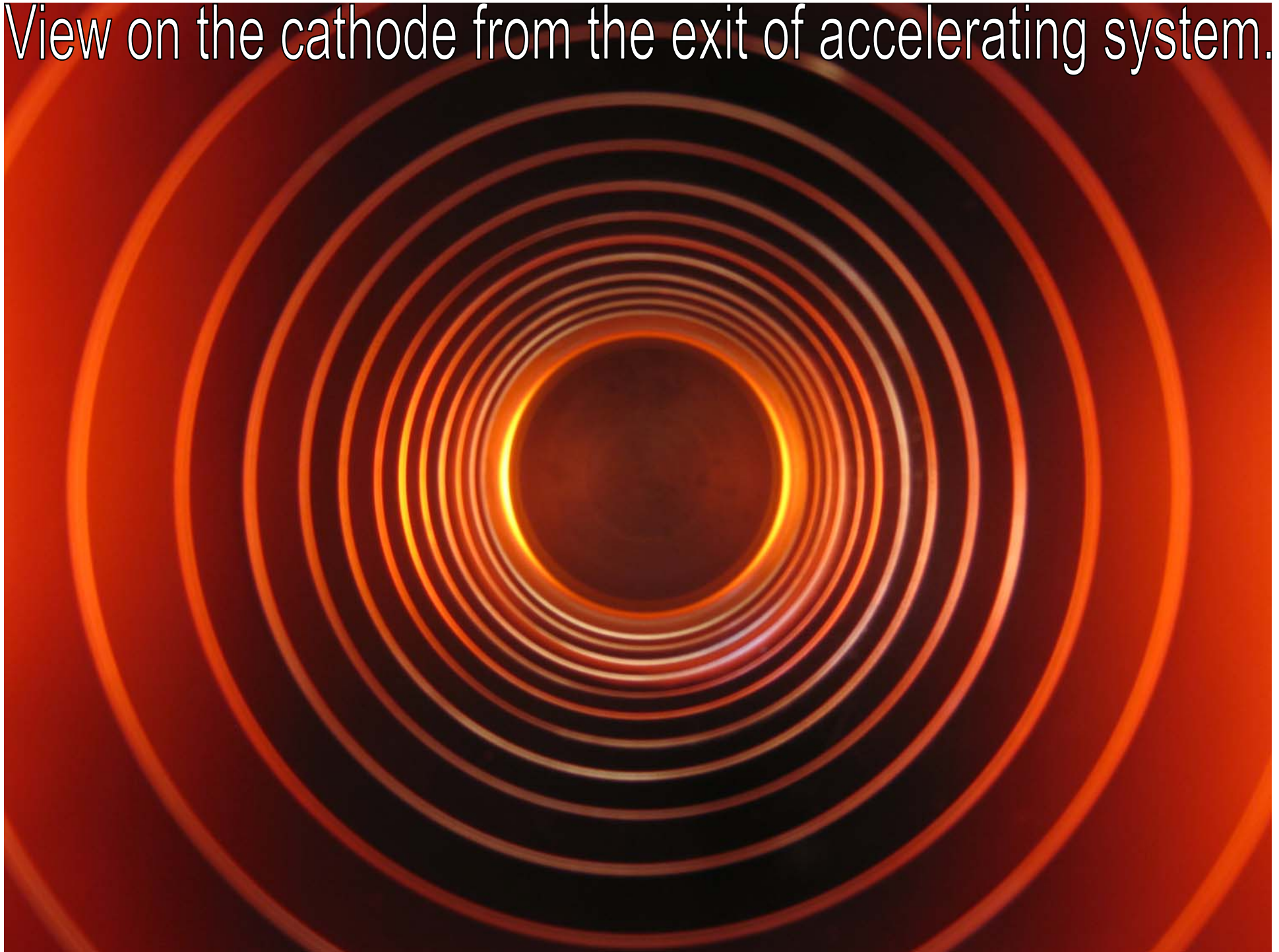
Ultra high vacuum 1 MV bit-slice bushing insulator.

LIA-2 diode.



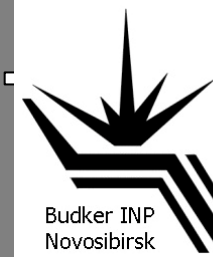
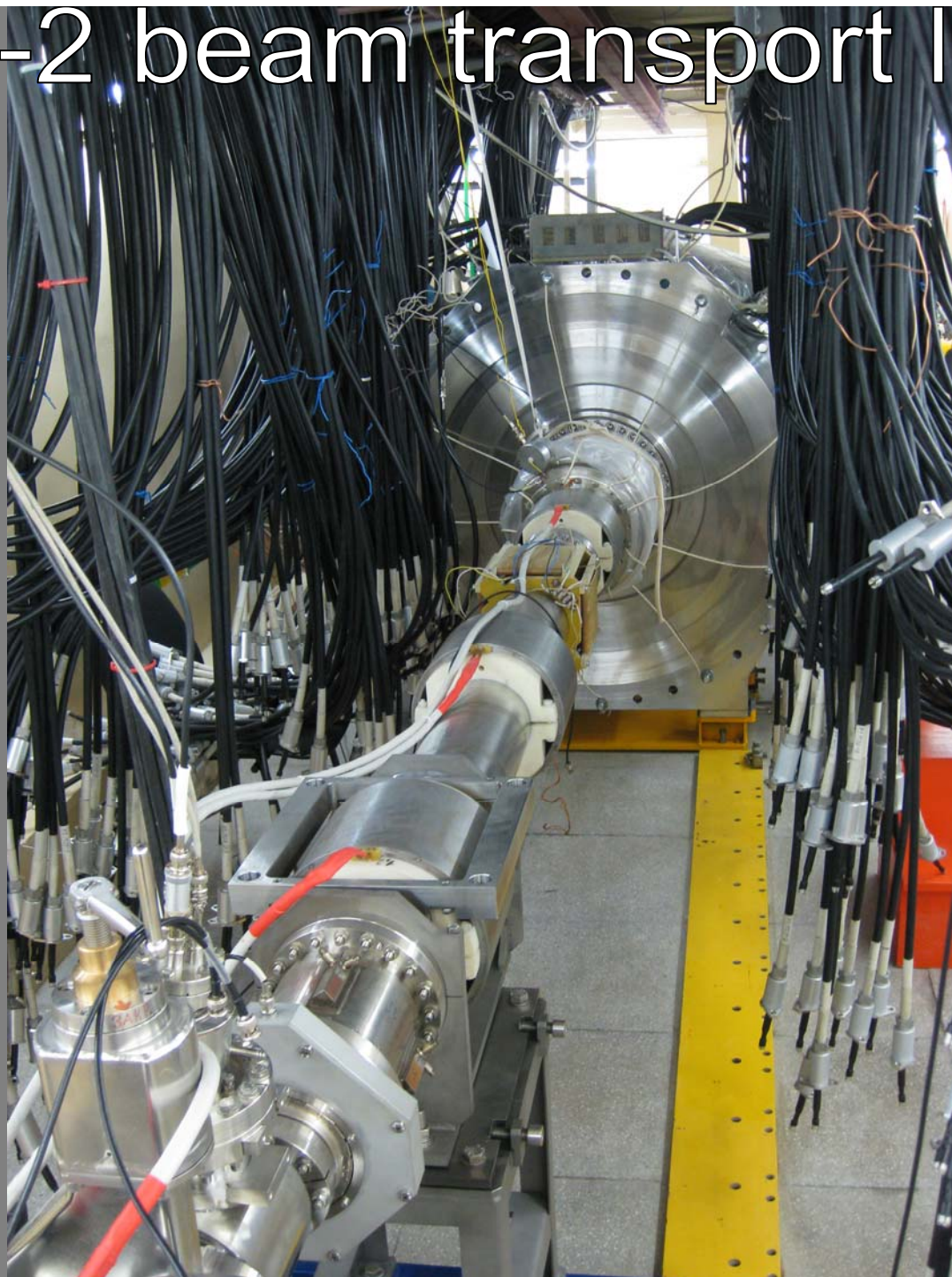
Microperviance: 2.18

View on the cathode from the exit of accelerating system.

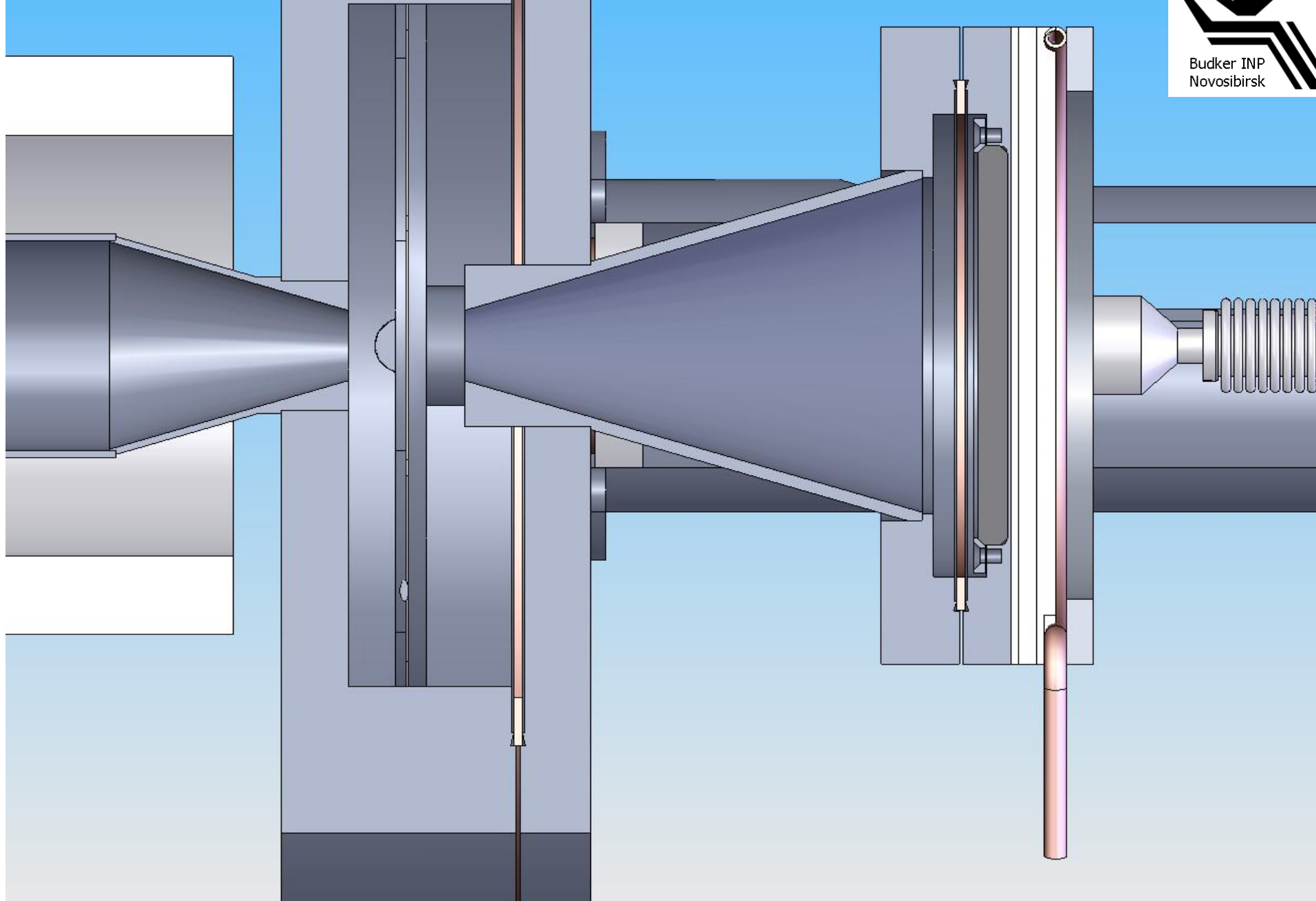
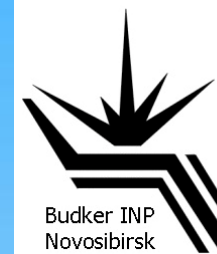




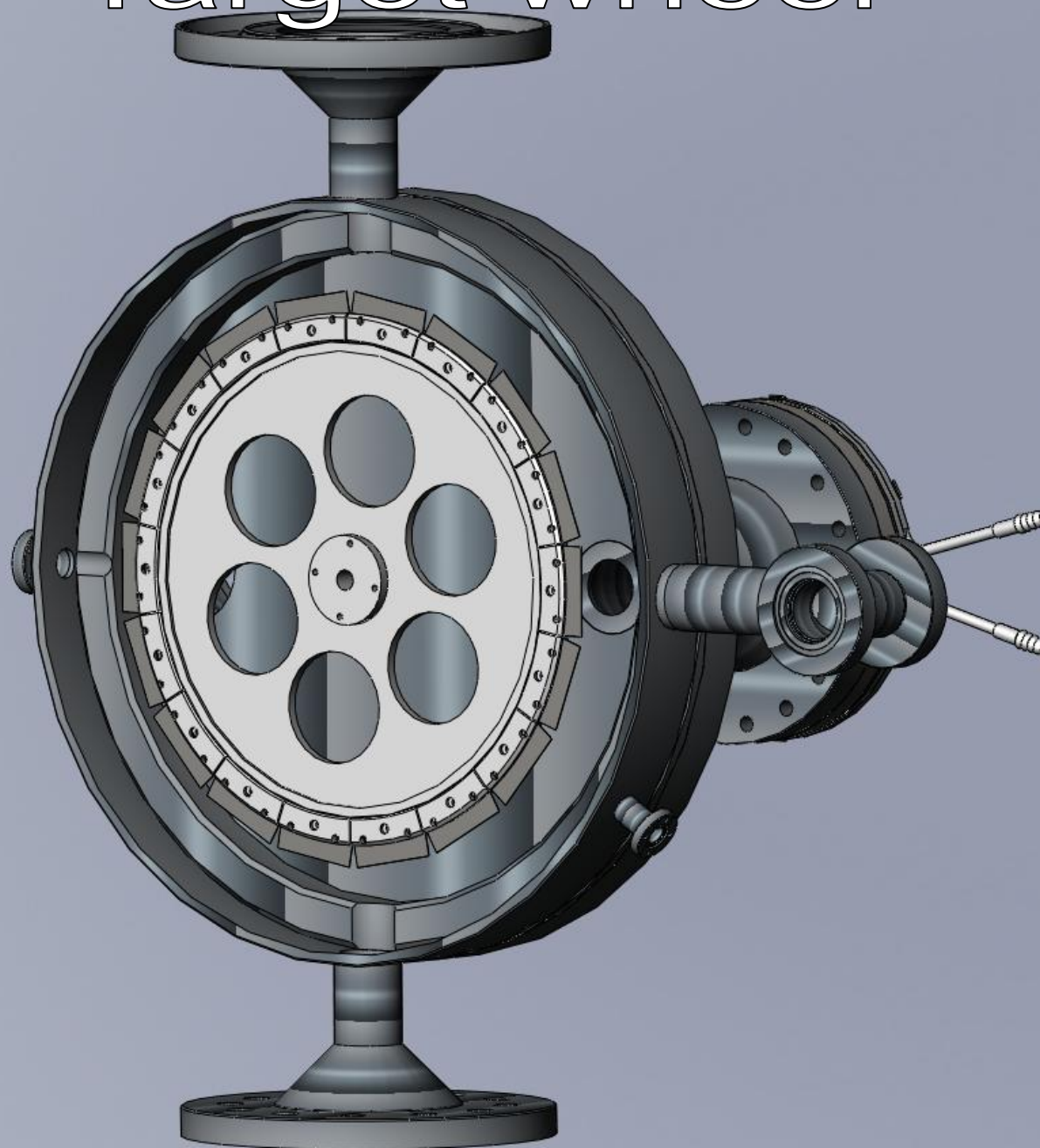
LIA-2 beam transport line.

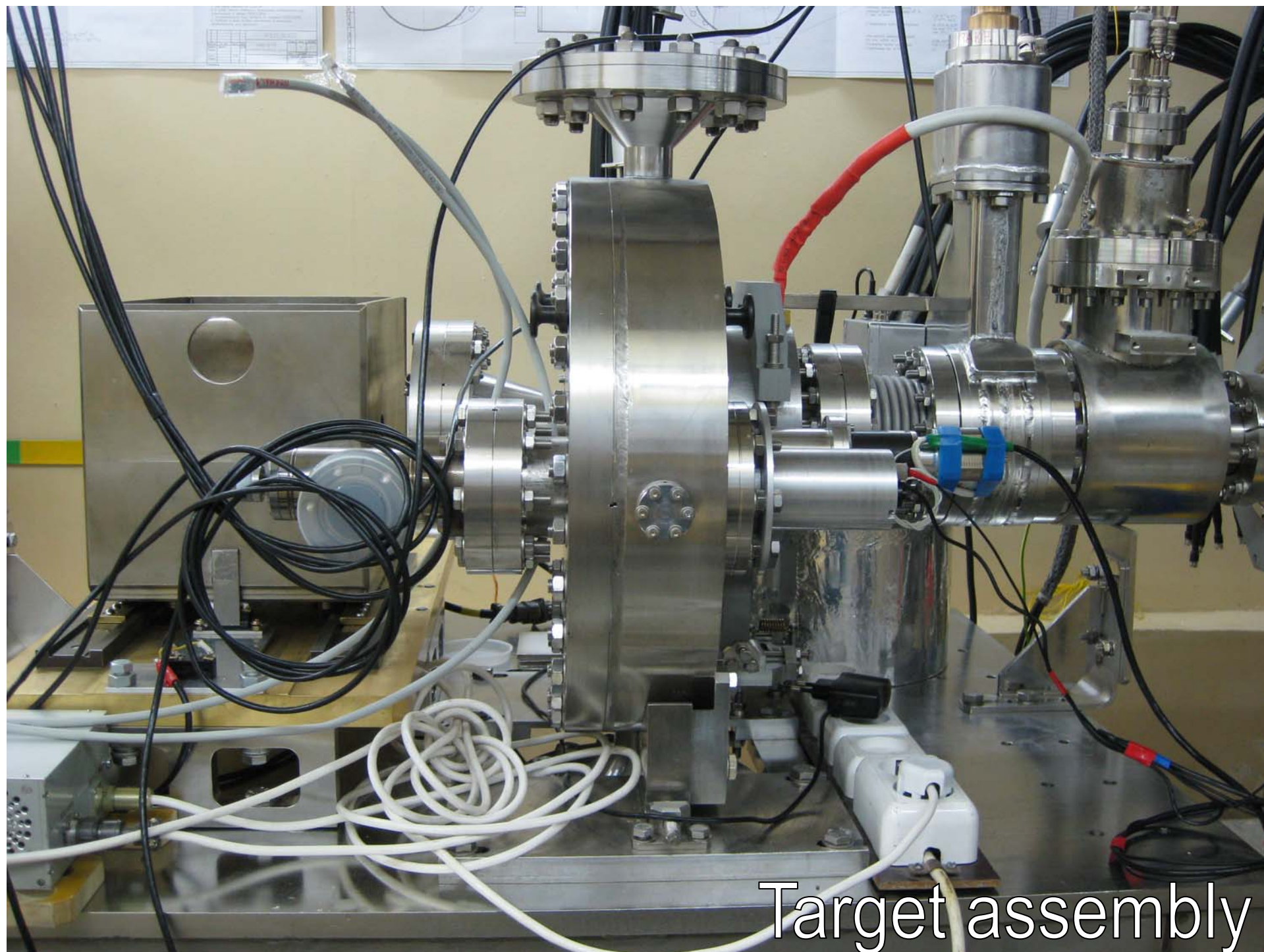


Rotating target and beam dump.



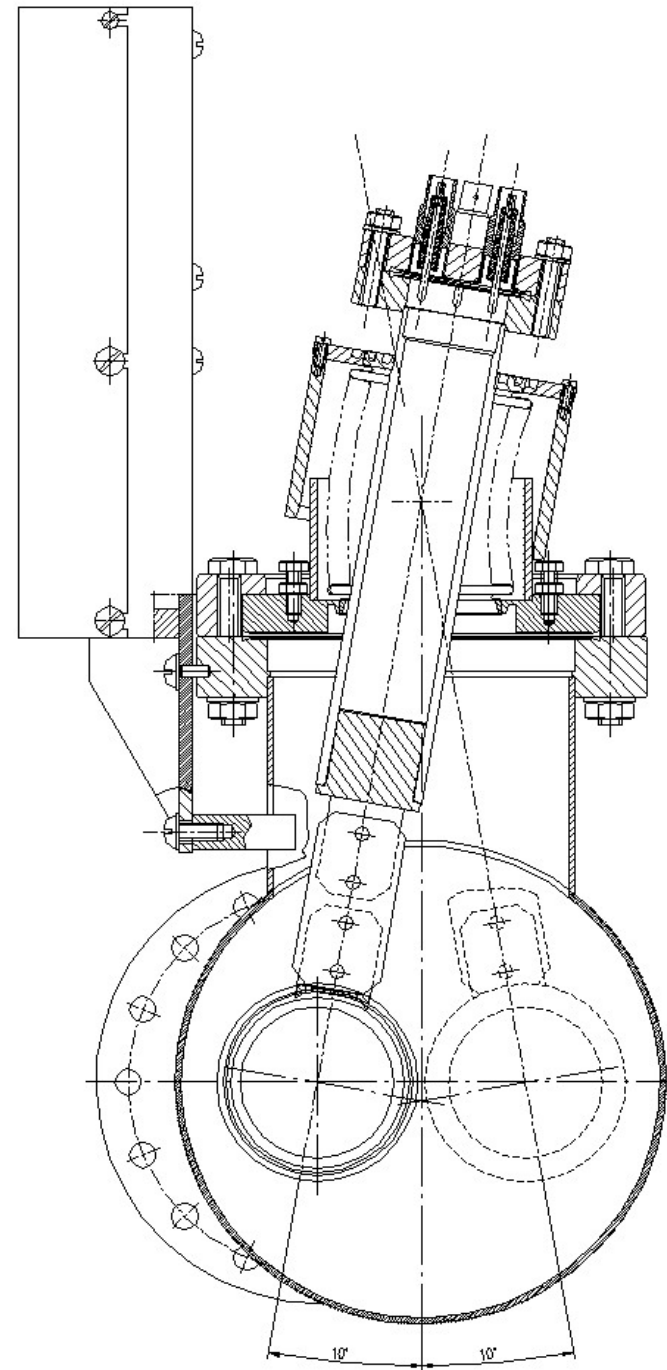
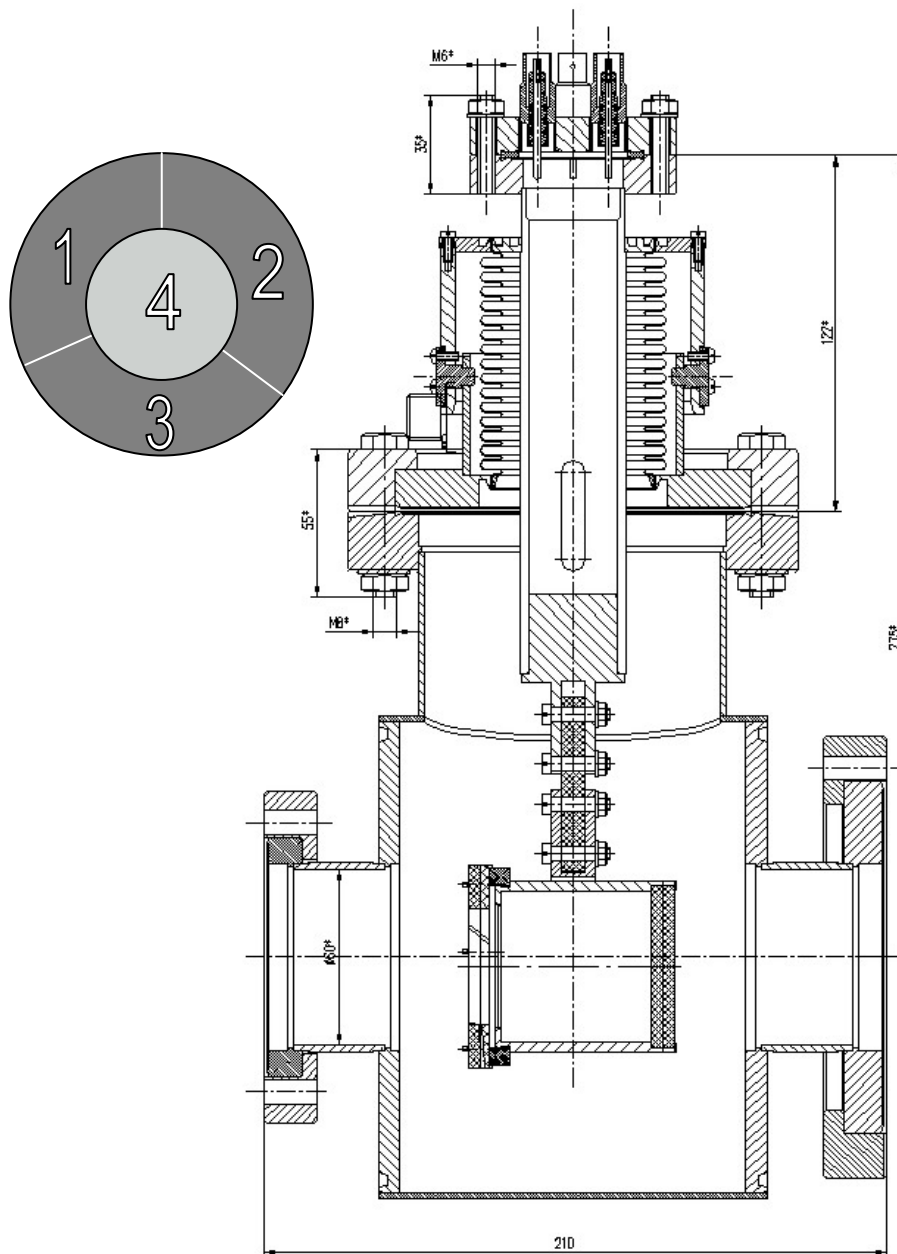
Target wheel



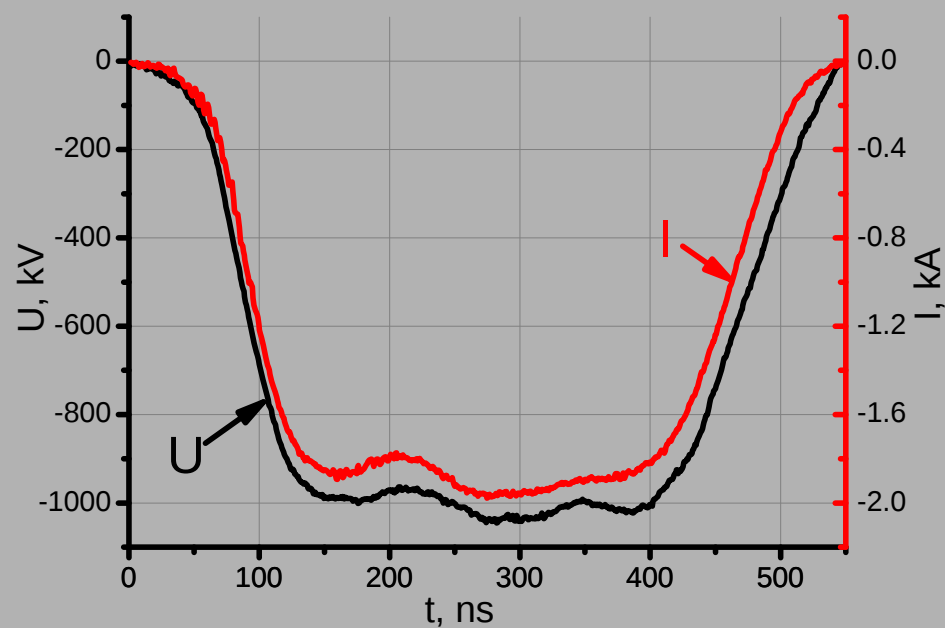
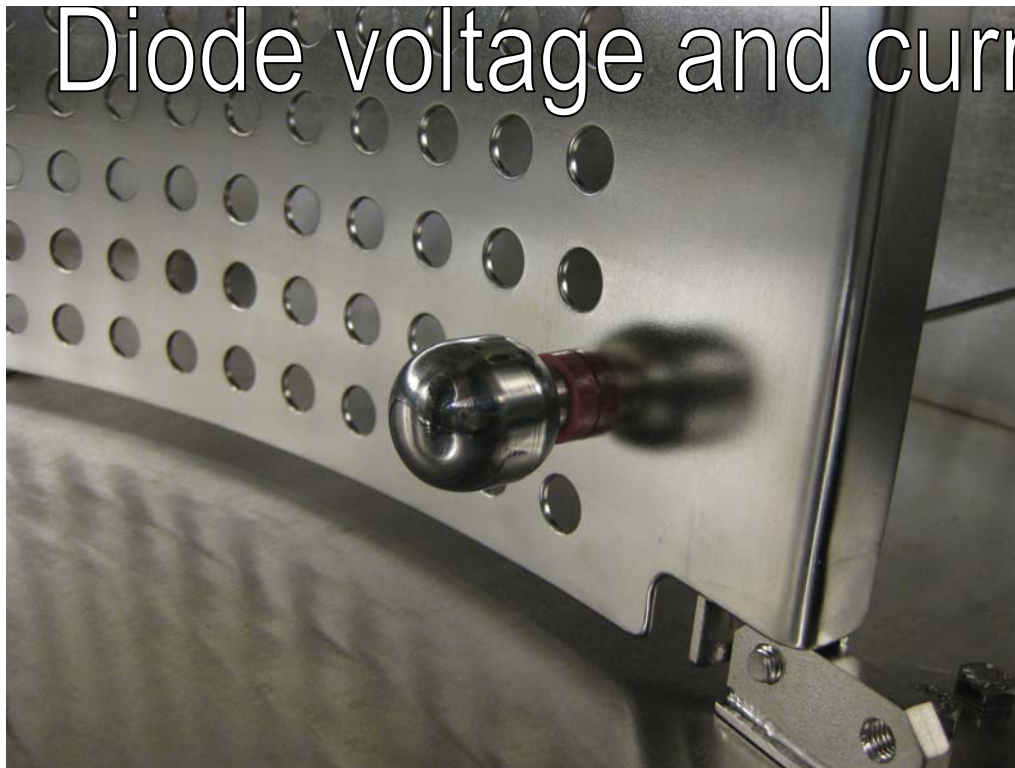


Target assembly

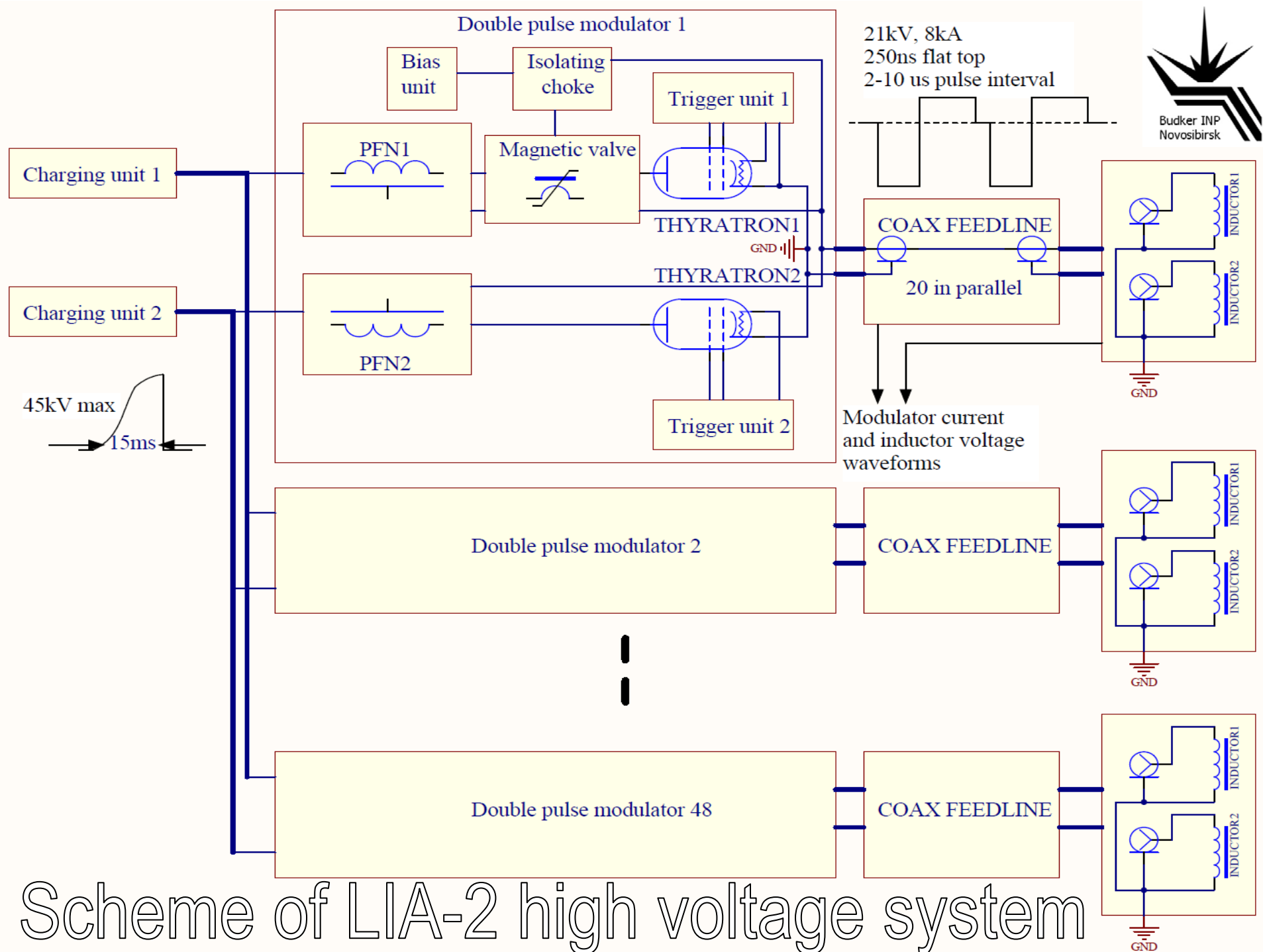
Faraday Cup



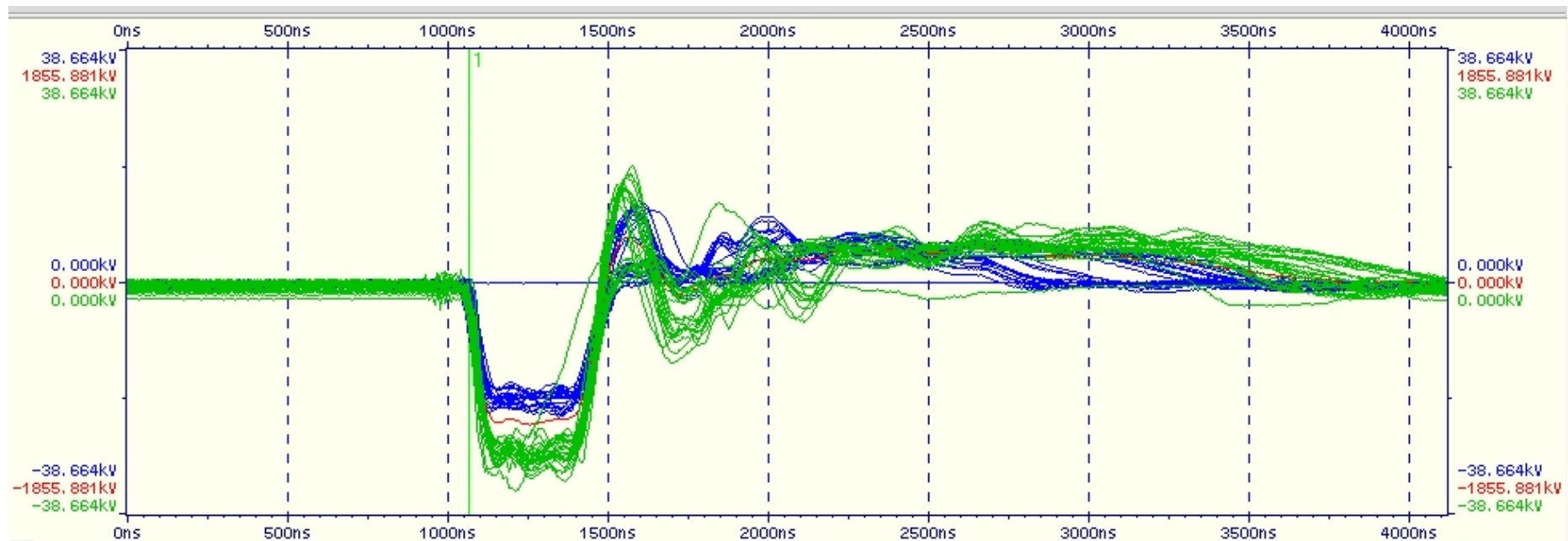
Diode voltage and current measurements

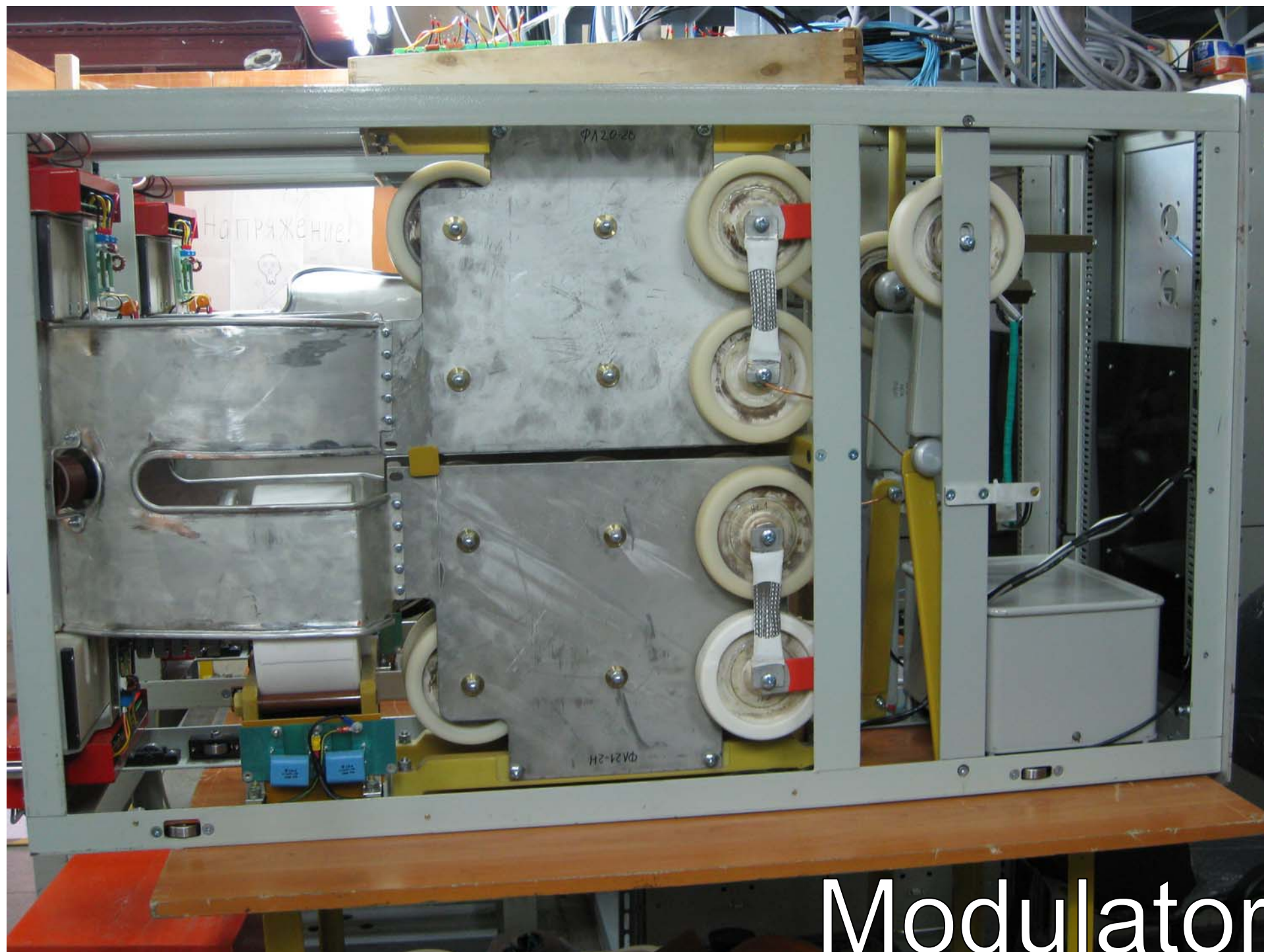


1000 kV, 2000 A.

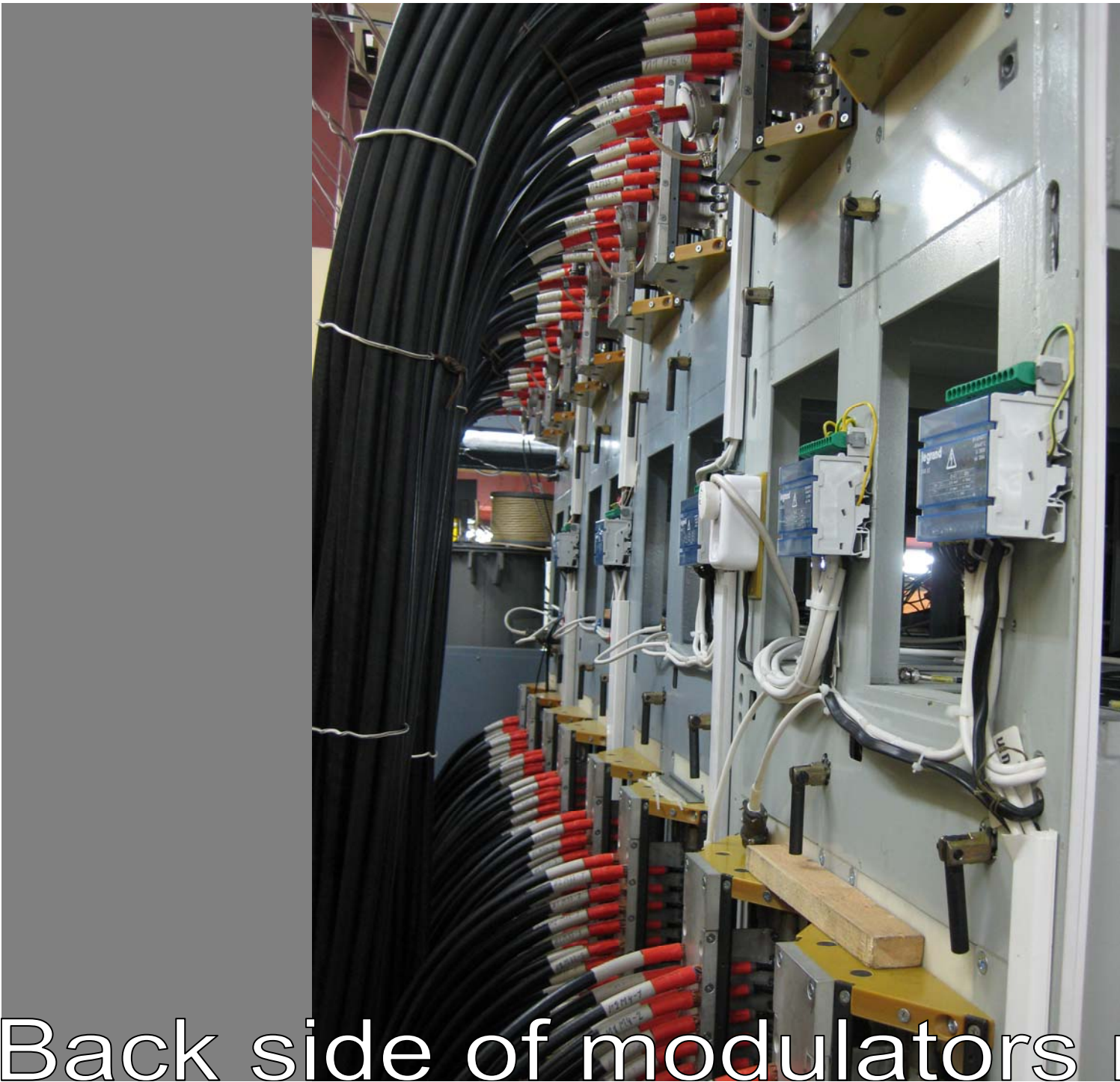


Voltage and current measurements in pulsed high voltage system.

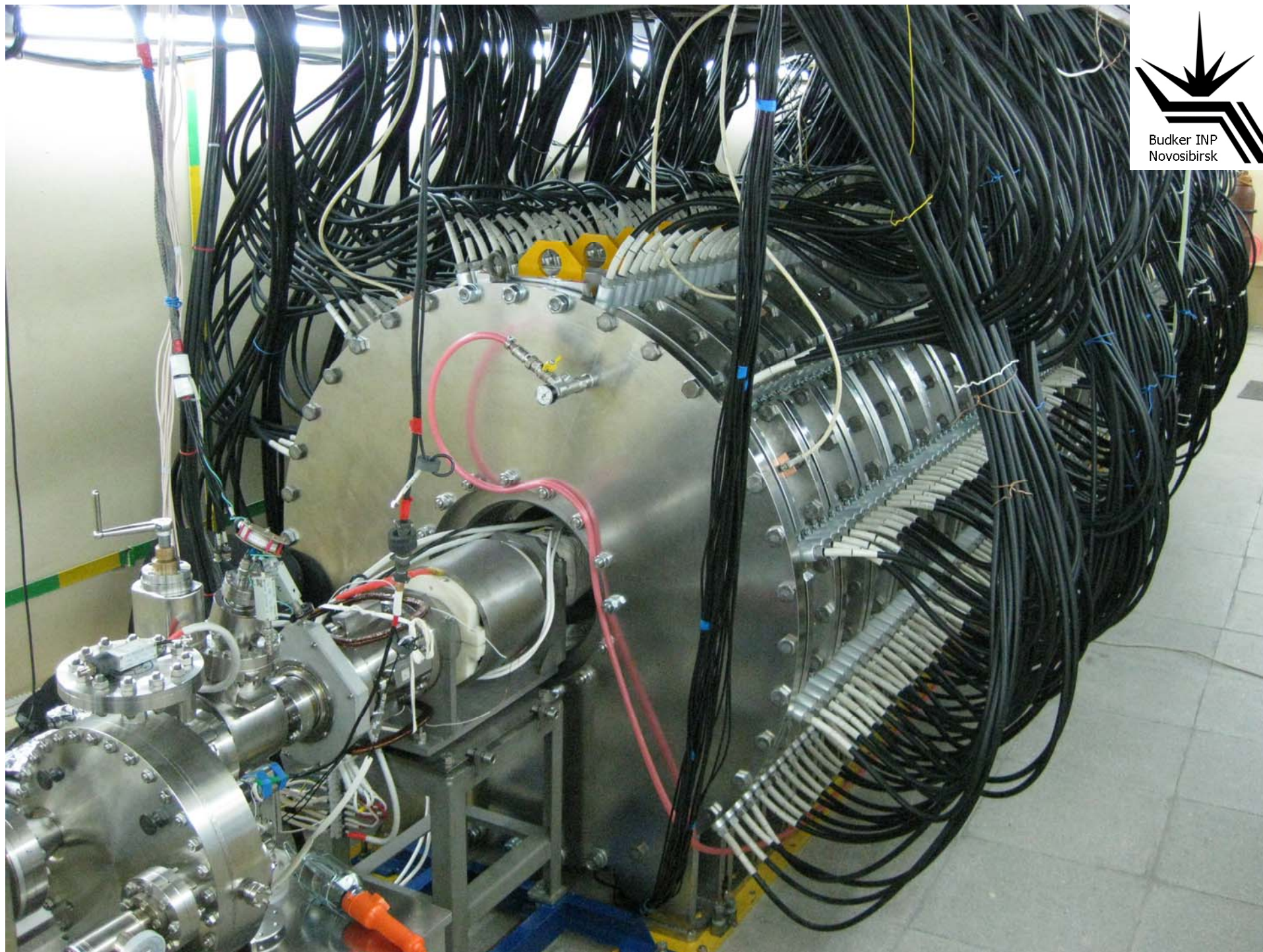








Back side of modulators racks

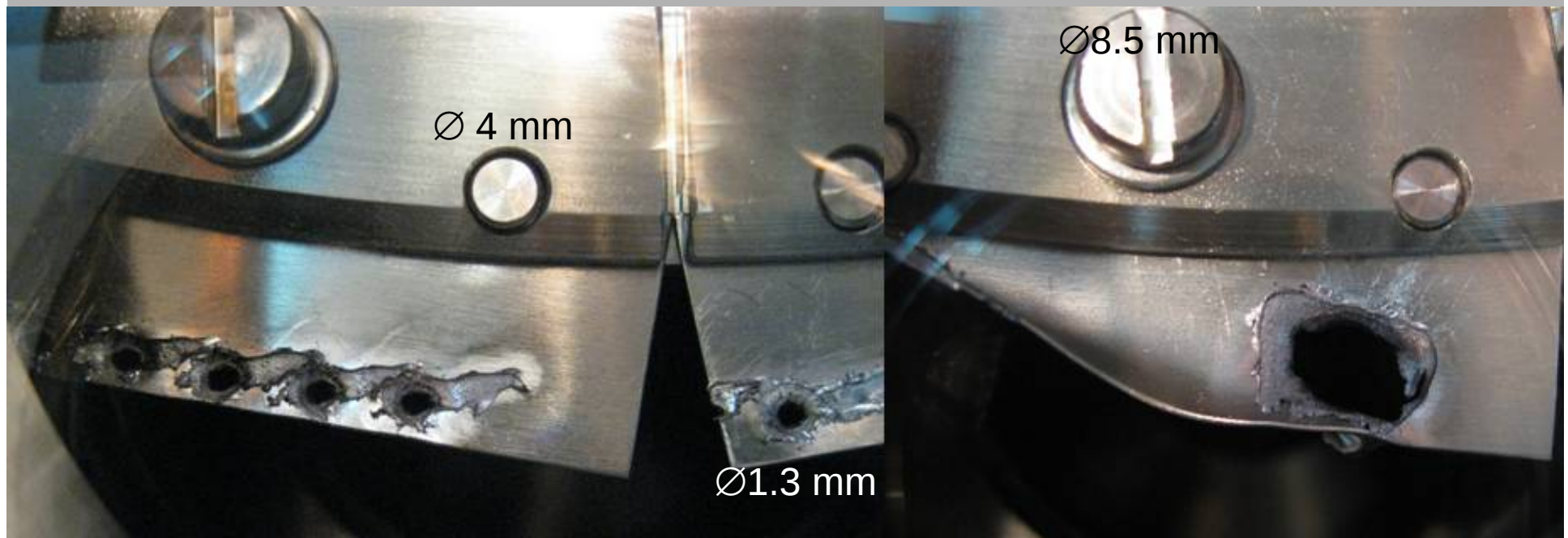








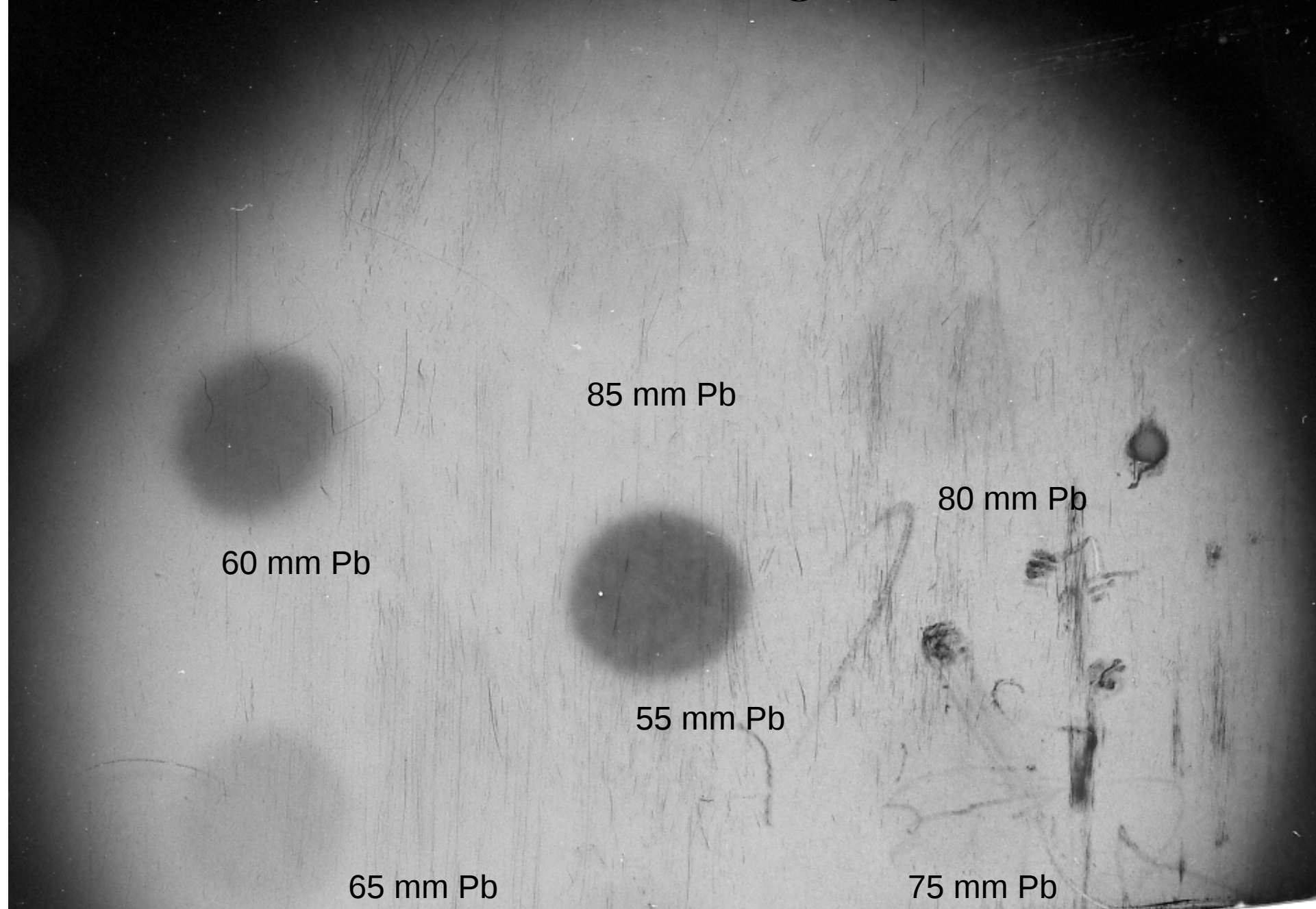
The results of beam interaction with 0.5 mm thick tantalum target for best beam focusing (on the left, 6 shots) and for smaller than optimum current in final focusing lens (on the right, 1 shot). All other parameters are the same for all shots and correspond to maximum beam energy and current (2 MeV, 2 kA, 200 ns). Bolt head diameter on the picture is equal to 8.5 mm, pin diameter – 4 mm.



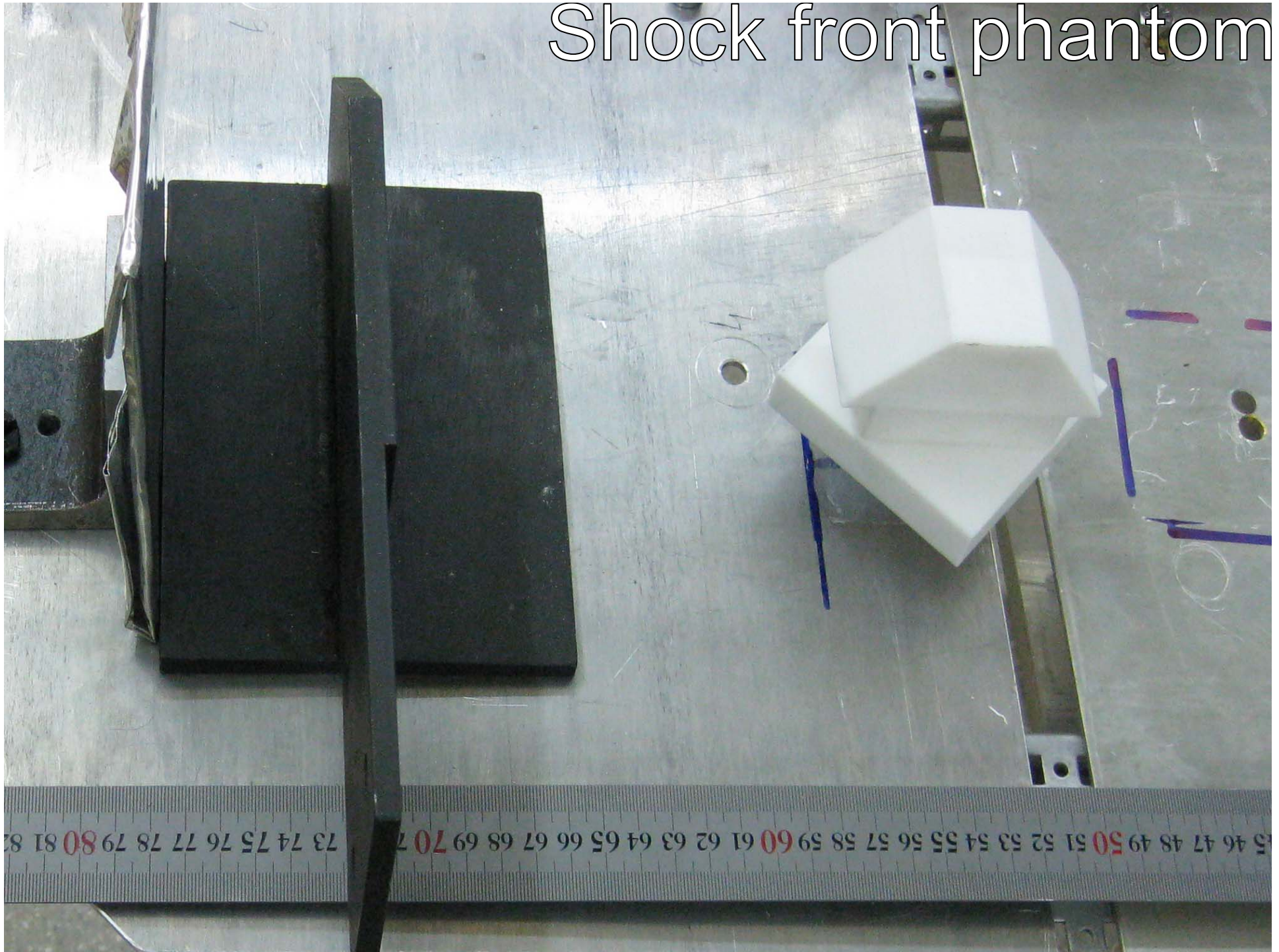


Wedge phantom

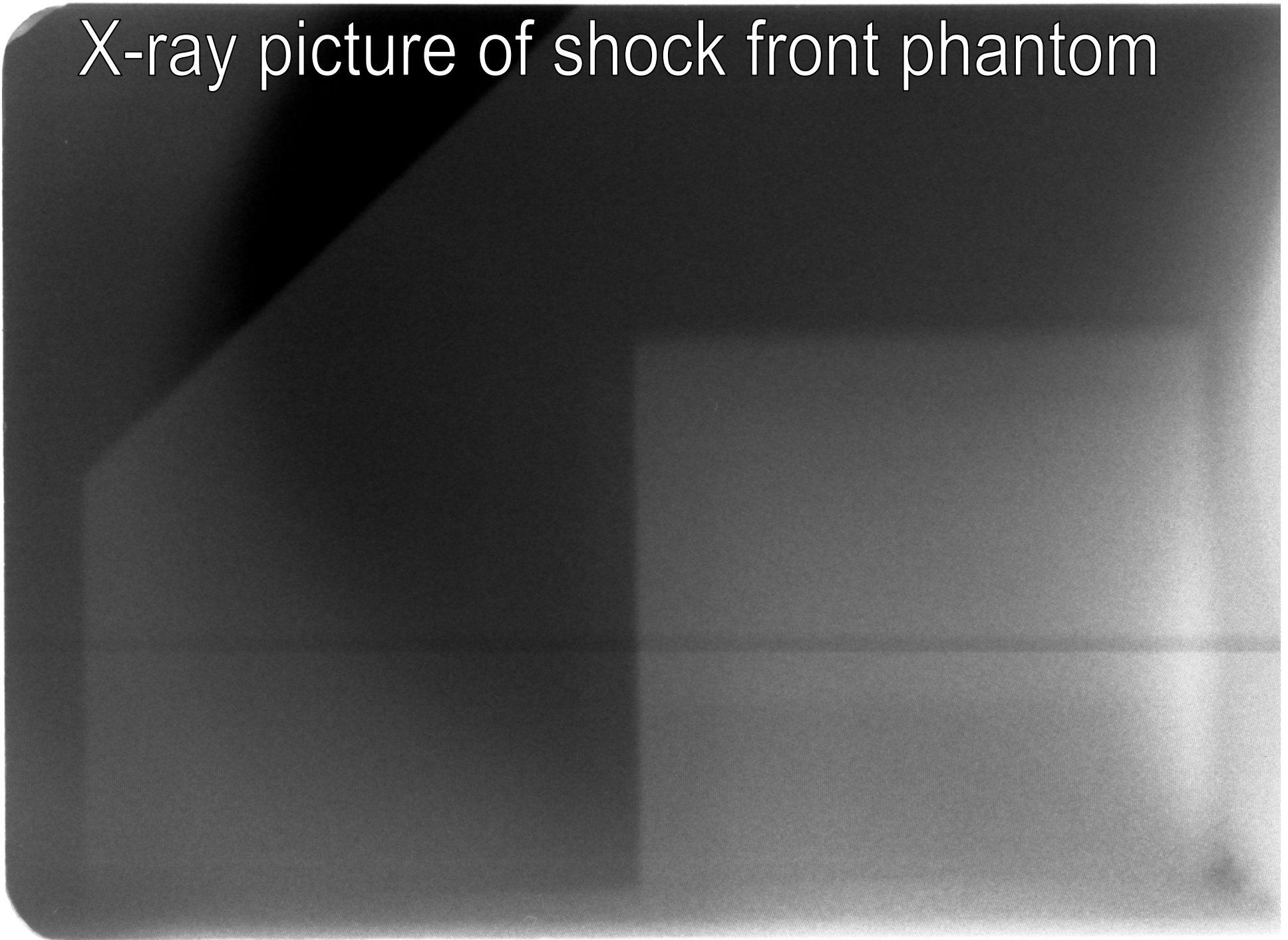
X-ray picture of wedge phantom



Shock front phantom

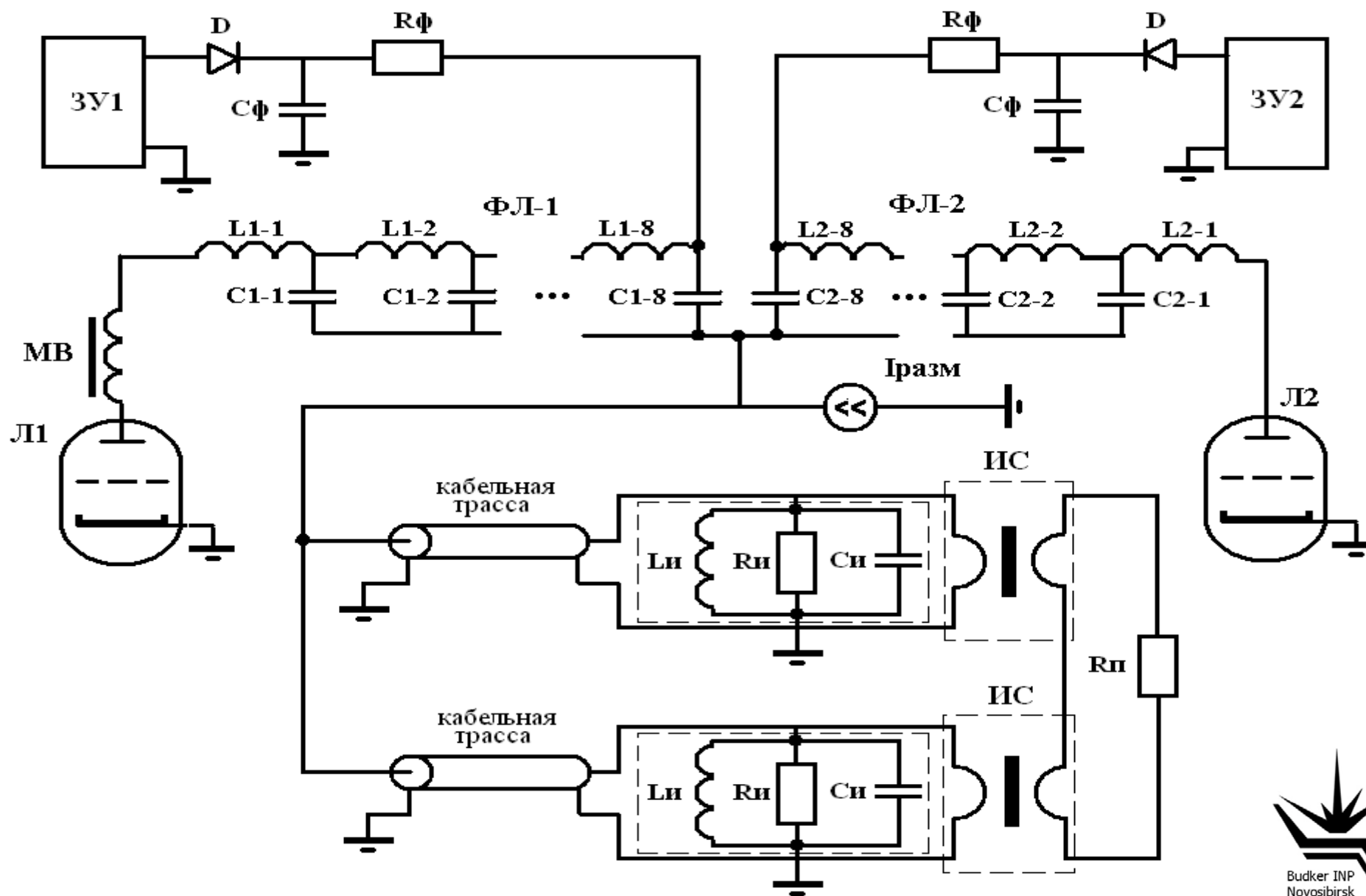


X-ray picture of shock front phantom

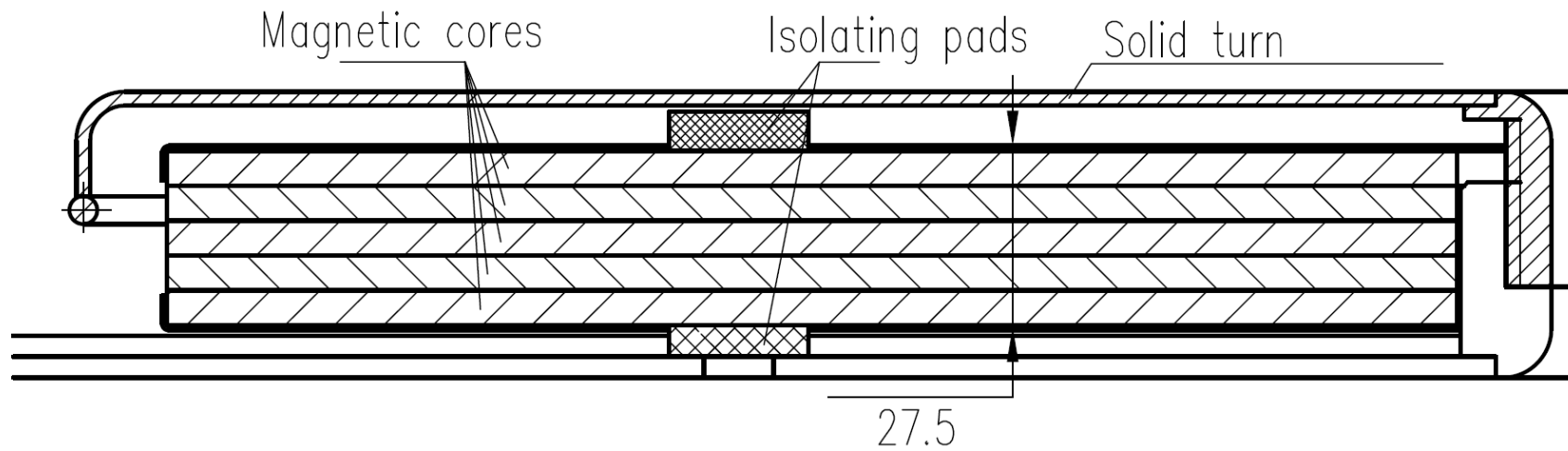


Thank you for your attention !

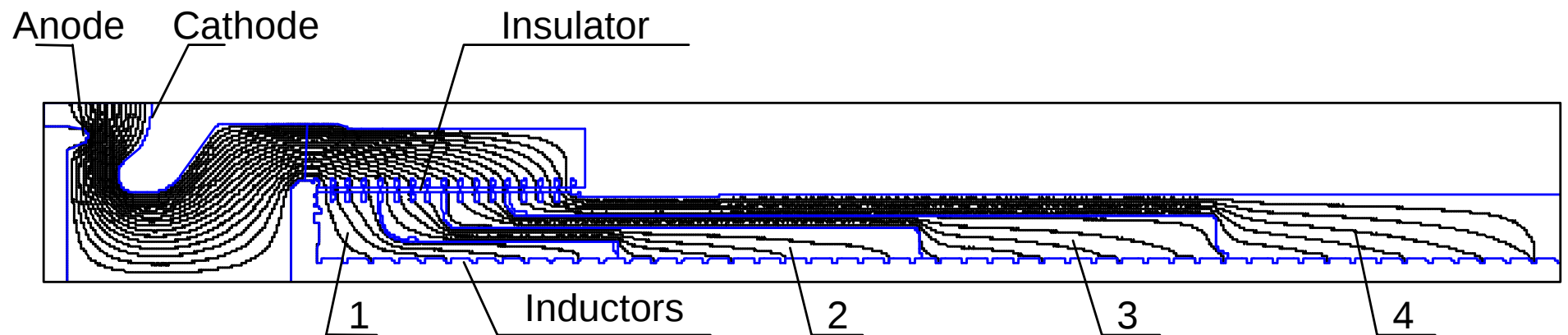
Scheme of LIA-2 pulsed high voltage system

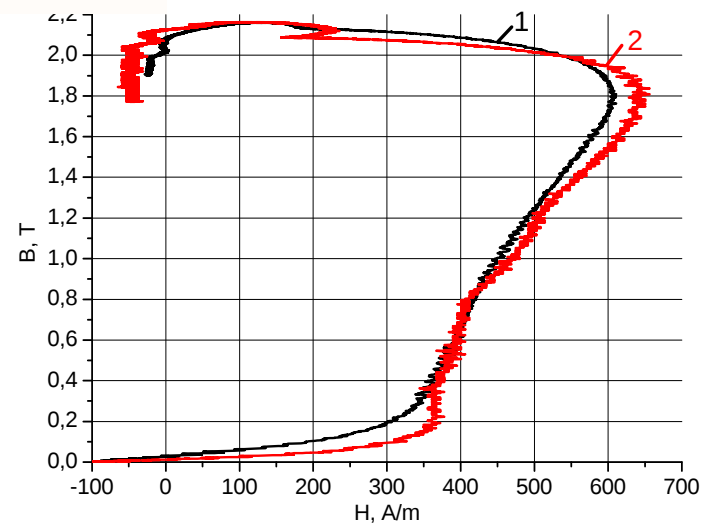
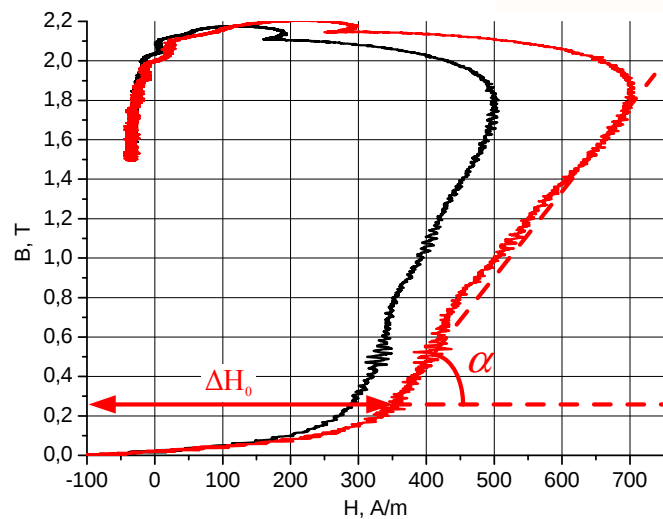
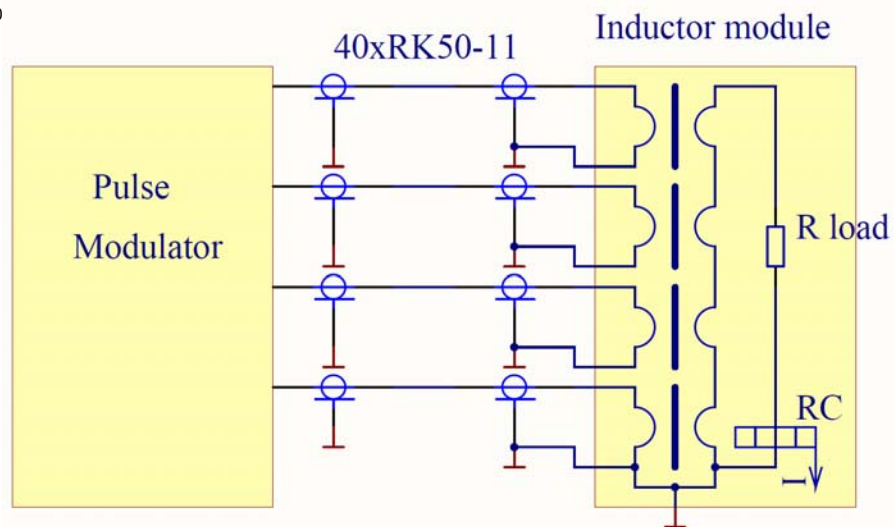
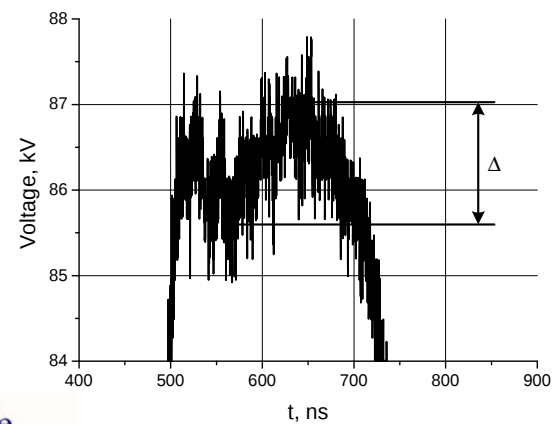
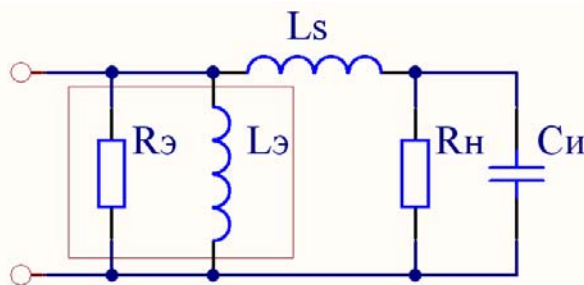
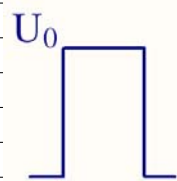
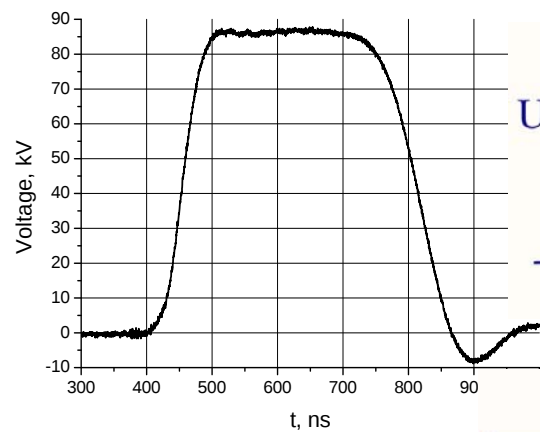


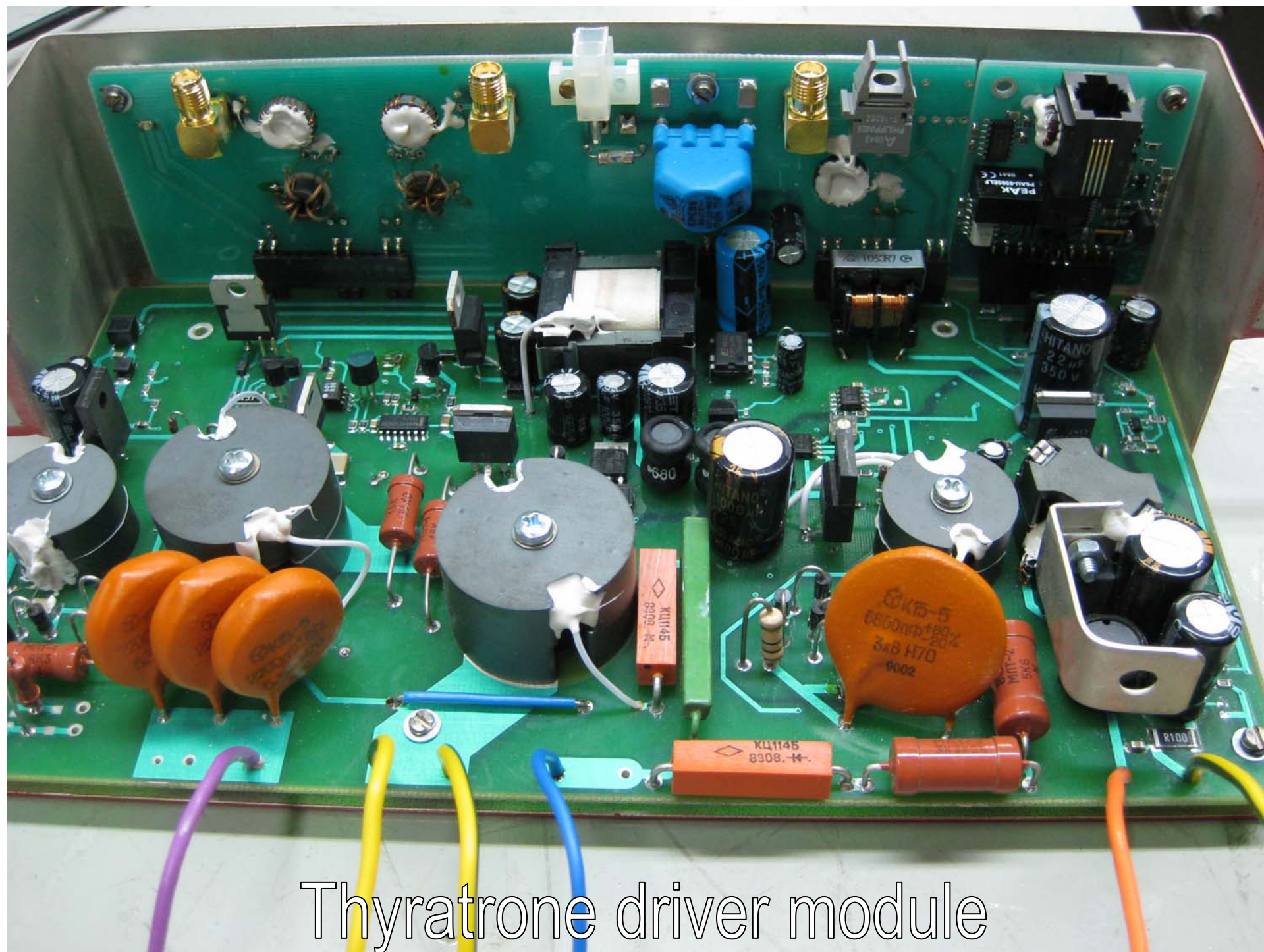
Inductor inner structure.



Equipotential lines distribution in diode high voltage system.





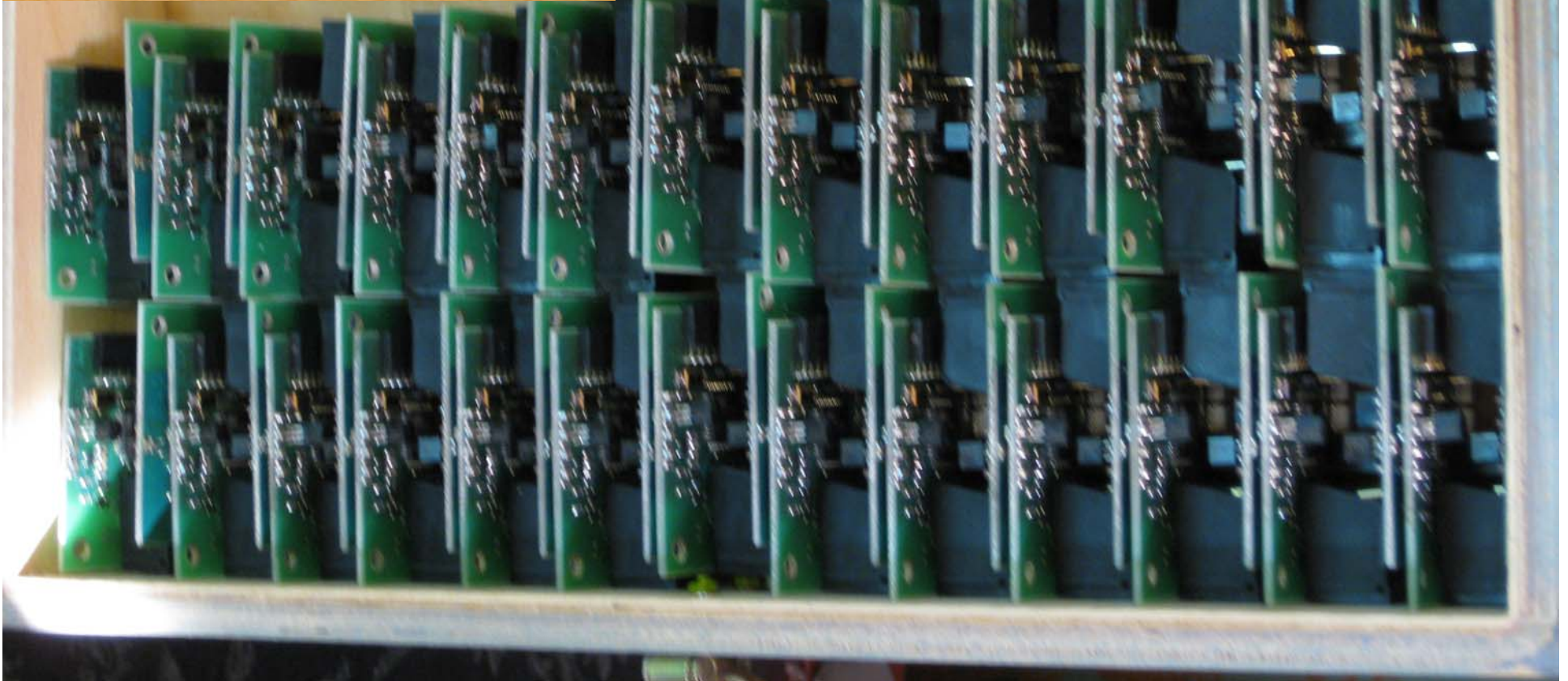
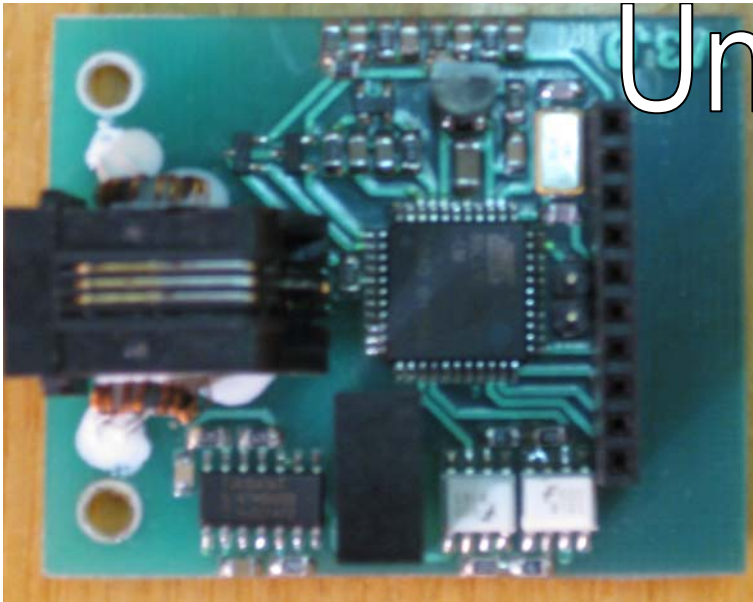


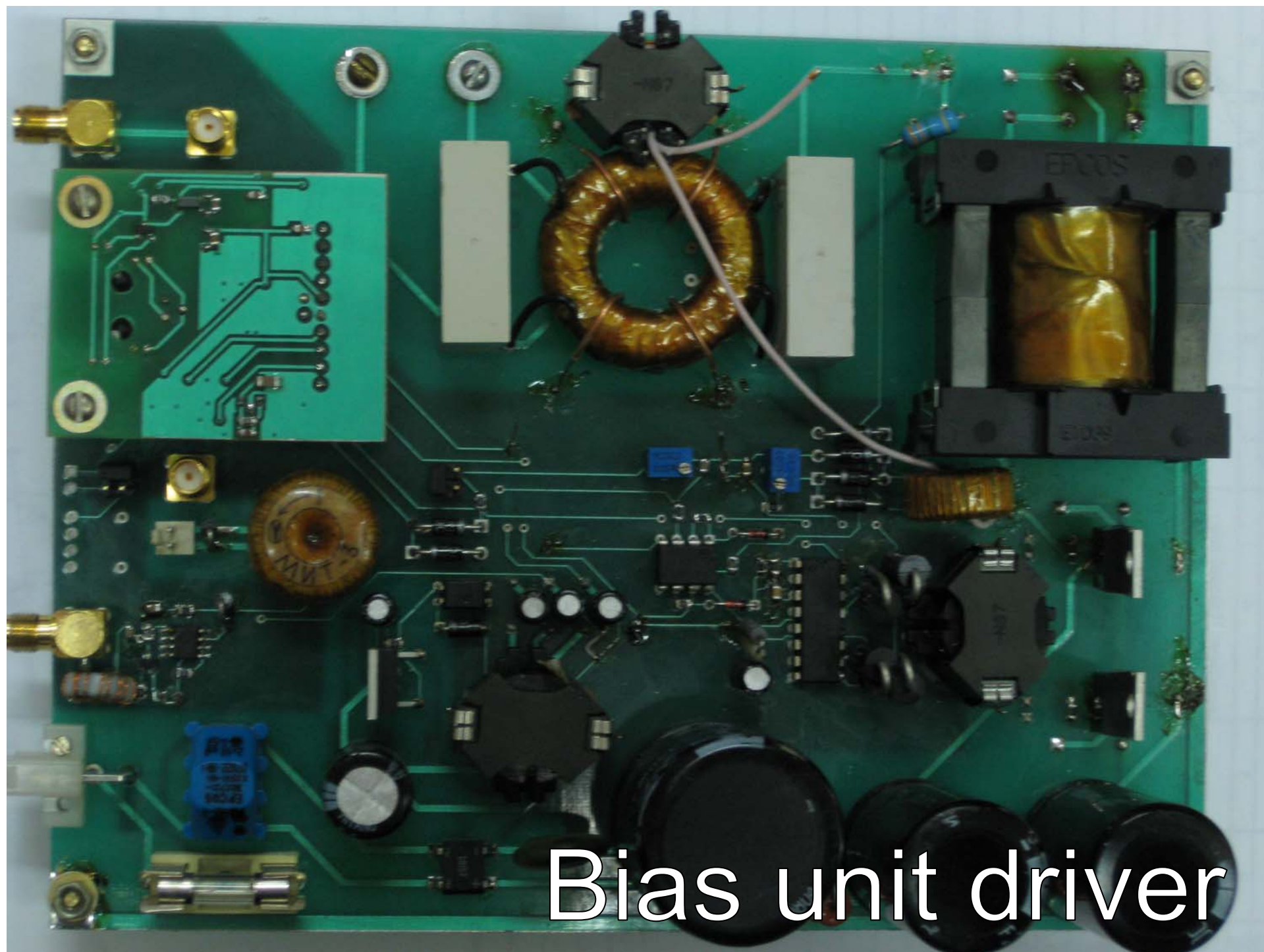
Thyatron driver module



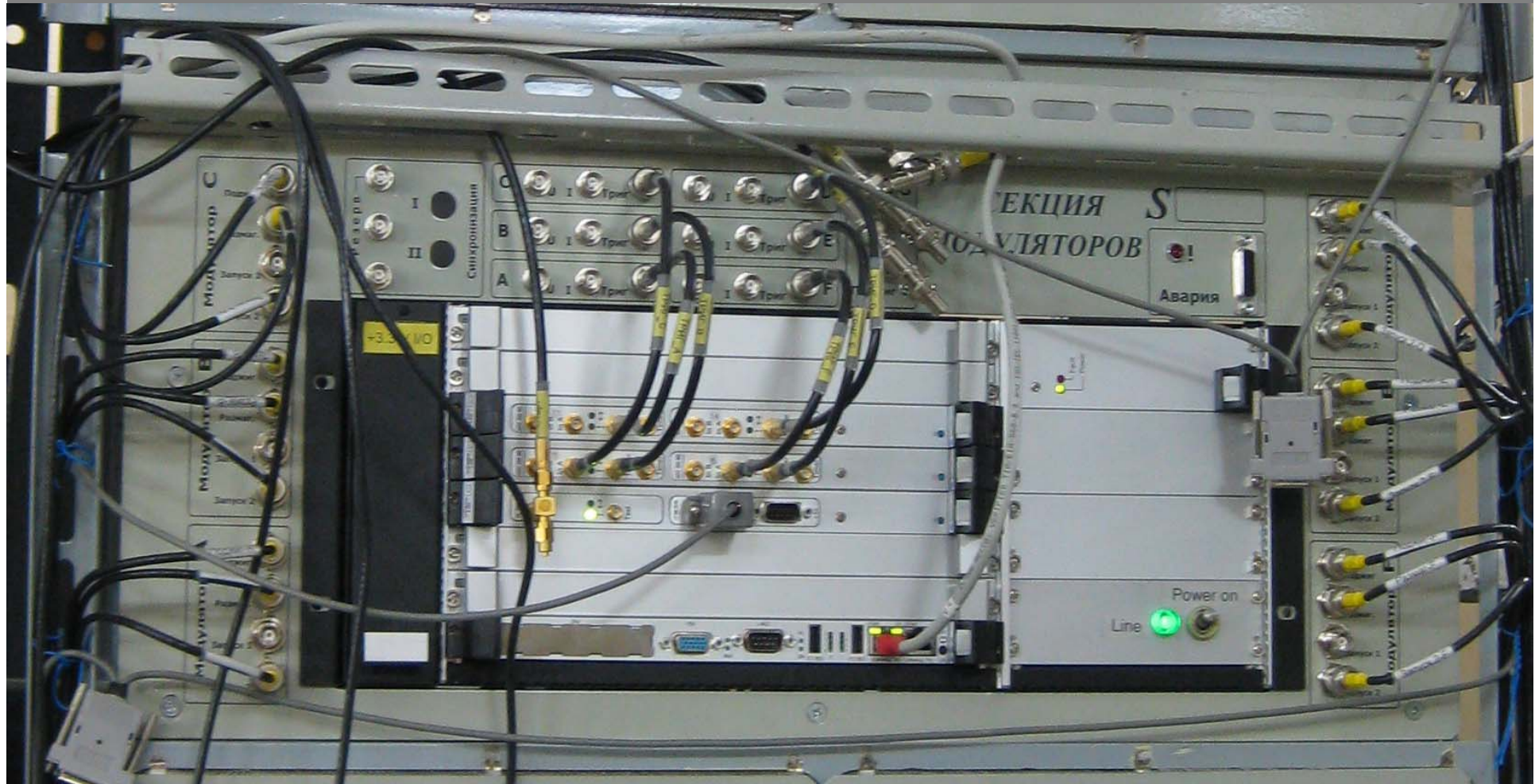
Modulator controllers

Universal unit controller





Compact PCI module for modulators control



Power supplies for cathode filament and beam focusing system

